



PATENTS

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: )  
Tzeng ) Group Art Unit: 1762  
Serial No: 09/501,114 ) Examiner: W. Markham  
Filed: February 10, 2000 ) Docket No. A029 1080  
For: Method of Plasma Enhanced )  
Chemical Vapor Deposition )  
of Diamond )

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TC 1700

PETITION FOR EXTENSION OF RESPONSE TIME  
SUBMISSION OF EXTENSION FEE  
FOR ONE MONTH EXTENSION

Assistant Commissioner for Patents  
Washington, D. C. 20231

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ORIGINALLY FILED

Sir:

Applicant petitions the Commissioner of Patents and Trademarks to extend the time for response to the Office Action dated **January 3, 2002**, for **one** month from **April 3, 2002** to **May 3, 2002**.

Submitted herewith is a check for **\$55.00** to cover the cost of the extension. The Commissioner is hereby authorized to charge any deficiency in the payment of the required fee(s) or credit any overpayment to Deposit Account No. **09-0528**. This form is submitted in duplicate.

04/29/2002 GTEFFERA 00000003 09501114

02 FC:215

55.00 OP

Respectfully submitted,

D. Scott Sudderth

Reg. No. 34,026

Attorney for Applicant

Date: April 17, 2002

Telephone: (404) 962-7527

Docket: A029 1080

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